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CONFIRMATION NO. 4607

SERIAL NUMBER 10/512,405	FILING OR 371(c) DATE 06/15/2005 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 474082002800
APPLICANTS Nobumitsu Takase, Tokyo, JAPAN; Hideshi Nishikawa, Tokyo, JAPAN; Makoto Ito, Tokyo, JAPAN; Koji Sueoka, Tokyo, JAPAN; Shinsuke Sadamitsu, Tokyo, JAPAN;				
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/04866 04/16/2003				
** FOREIGN APPLICATIONS ***** JAPAN 2002-127509 04/26/2002 JAPAN 2002-360731 12/12/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <u>Examiner's Signature</u> <u>Initials</u>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 6	TOTAL CLAIMS 17
INDEPENDENT CLAIMS 4				
ADDRESS 25227				
TITLE High resistance silicon wafer and method for production thereof				
FILING FEE RECEIVED 1594	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	